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BEYER WEAVER & THOMAS, LLP

INTELLECTUAL PROPERTY LAW

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FACSIMILE COVER SHEET

October 18, 2006

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Francis T. Kalinski II

Registration No. 44,177

Our Ref. No.: 03-2051/LSI1P240

Re:

U.S. Patent Application No. 10/791,337

Filed: March 1, 2004

Title: SPACER-LESS TRANSISTOR INTREGRATION SCHEME FOR HIGH-K GATE DIELECTRICS AND SMALL GATE-TO-GATE SPACES APPLICABLE TO SL SIGE AND STRAINED SILICON SCHEMES

Pages Including Cover Sheet(s): 12

MESSAGE:

Please file the attached Amendment B in the referenced matter.

CONFIDENTIALITY NOTE

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: PRITCHARD et al.

Attorney Docket No .:

03-2051/LSI1P240

Application No.: 10/791,337

Filed: March 1, 2004

Examiner: TRINH, Michael Manh

Title: SPACER-LESS TRANSISTOR

Group: 2822

INTEGRATION SCHEME FOR HIGH-K GATE

Confirmation No.: 2401

DIELECTRICS AND SMALL GATE-TO-GATE

SPACES APPLICABLE TO SI, SIGE AND

STRAINED SILICON SCHEMES

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being transmitted by facsimile to fax number 571-273-8300 to the U.S. Patent and Trademark Office on October 18,

AMENDMENT B TRANSMITTAL

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

 \boxtimes

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
21	MINUS	22	0	x 25 =	x 50 = \$-0-
4	MINUS -	3	1	x 100 =	x 200 = \$200
dent Claim Pre	sent and Fe	e Not Previous	ly Paid		
			Total	\$	\$200
	Amendment 21 4 dent Claim Pre	Amendment 21 MINUS 4 MINUS dent Claim Present and Pe	Amendment Paid For 21 MINUS 22 4 MINUS 3 dent Claim Present and Fee Not Previous	Amendment Previously Paid For Extra 21 MINUS 22 0 4 MINUS 3 1 dent Claim Present and Fee Not Previously Paid Total	Amendment Paid For Extra Rate Fee 21 MINUS 22 0 x 25 = 4 MINUS 3 1 x 100 = dent Claim Present and Fee Not Previously Paid

determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 12-2252 (Order No. 03-2051).

Enclosed is our Check No.

in the amount of \$ to cover the additional

claim fee and/or extension of time fees.

Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 12-2252 (Order No. 03-2051).

Respectfully submitted

BEYER WEAVER & THOMAS, LLP

Francis T. Kalinski II Registration No. 44,177

P.O. Box 70250 Oakland, CA 94612-0250

PAGE 2/12 * RCVD AT 10/18/2006 2:53:40 PM [Eastern Daylight Time] * SVR:USPTO-EFXRF-6/37 * DNIS:2738300 * CSID:16509618301 * DURATION (mm-ss):03-26

OCT 18 2008

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: PRITCHARD et al.

Attorney Docket No.:

Application No.: 10/791,337

03-2051/LSI1P240

Filed: March 1, 2004

Examiner: TRINH, Michael Manh

-,--,

Group: 2822

Title: SPACER-LESS TRANSISTOR INTEGRATION SCHEME FOR HIGH-K GATE

DIELECTRICS AND SMALL GATE-TO-GATE

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SPACES APPLICABLE TO SL SIGE AND

STRAINED SILICON SCHEMES

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being transmitted by facsimile to fax number 571-273-8300 to the U.S. Patent and Trademark Office on October 18, 2006.

Signed:

Sue Funchial
Sue Funchess

AMENDMENT B

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated September 11, 2006, please amend the above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

10/19/2006 TL0111

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91 FC:1281

200.08 DA

Atty. Dkt. No. 03-2051/LSI1P240

App. No. 10/791,337